REPLACEMENT SHEET
06 JUN 2002

AGGREGATE DIELECTRIC LAYER TO REDUCE NITRIDE CONSUMPTION

ABSTRACT

A method including over a substrate, forming an aggregate comprising a barrier layer between a first dielectric layer comprising nitrogen and a second dielectric layer comprising phosphorous, and after forming the aggregate, thermally treating the substrate. An apparatus including a substrate and an aggregate formed over the substrate including a barrier layer between a first dielectric layer comprising nitrogen and a second dielectric layer comprising phosphorous.

Figure 4

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